

Enter  
w/RCE  
7/6/07



Docket No.: 050389-0052

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Chihiro KAWAI, et al.

RESPONSE UNDER 37 CFR 1.116  
EXPEDITED PROCEDURE

Application No.: 10/500,975

Customer No.: 20277  
Confirmation No.: 3373

Filed: July 08, 2004

Group Art Unit: 2811

Examiner: Andrew O. Arena

Title: POROUS SEMICONDUCTOR AND METHOD FOR MANUFACTURING SAME

AMENDMENT UNDER 37 CFR 1.116

Mail Stop AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

The following Remarks and Amendment are submitted in response to the Office Action  
dated February 7, 2007.

Amendments to the Claims begin on page 2 of this paper.

Remarks begin on page 15 of this paper.

Do Not Enter  
A.O.A. 25 June 2006

05/31/2007 JADD01 00000158 500417 10500975  
01 FC:1201 1200.00 DA